



PATENT
03371-P0005A LHR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Lynn David Bollinger, <i>et al.</i>
Serial No. 09/693,117	Filing Date: October 20, 2000
Title of Application:	Method for Rapid Thermal Processing of Substrates
Confirmation No.	Group Art Unit: 2812
Examiner	Mary Wilezewski

Assistant Commissioner for Patents
Washington, DC 20231

Information Disclosure Statement by Applicants

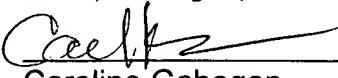
Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references.

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
MW	357/65	4,783,695	11/08/88	Eichelberger <i>et al.</i>
MW	437/173	5,302,547	04/12/94	Wojnarowski <i>et al.</i>
MW	427/96	5,314,709	05/24/94	Doany <i>et al.</i>
MW	216/65	5,830,376	11/03/98	Bohlke <i>et al.</i>

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February 14, 2003


Caroline Gahagan